

Agilent Intuvo 9000 Gas Chromatograph System

Chromatographic performance*

- Retention time repeatability <0.008% or <0.0008 minutes
- Area repeatability <1% RSD

System capabilities

- Supports:
 - Inlets: SSL, MMI
 - Detectors: FID, TCD, ECD, NPD, FPD, SCD/NCD, Mass Spec (single and triple quad)
 - Four detector signals
- State-of-the-art detector electronics and the full-range digital data path enable peaks to be quantified over the entire concentration range of the detector (10⁷ for the FID) in a single run.
- Full EPC is available for all inlets and detectors. Control range and resolution are optimized for the specific inlet or detector module.
- Pressure setpoint and control precision to 0.001 psi provides more retention time locking precision for low-pressure applications.
- EPC provides four column flow control modes: constant pressure, ramped pressure (three ramps), constant flow, or ramped flow (three ramps). Column average linear velocity is calculated.
- Atmospheric pressure and temperature compensation is standard, so results do not change, even when the laboratory environment changes.

- Automatic leak checking can be enabled by user for every run or run any time during maintenance or diagnostic tasks. System alerts the user when a leak is detected so immediate action can be taken to correct and minimize downtime.
- A run time deviation log is created for each analysis to ensure that all method parameters were achieved and maintained.
- Automatic Liquid Sampling is fully integrated into GC control.
- Display of all GC and ALS setpoints at the GC or data system.
- Built-in context sensitive help available on color touchscreen interface.
- Web interface available to view status, user information, and monitor runs.

GC color touchscreen interface

Available in English, Chinese, or Japanese

Column oven

- Accommodates up to two 30 m × 0.320 mm id capillary columns or one 60 m × 0.320 mm id capillary column
- Support columns 0.150 mm to 0.320 mm id
- Operating temperature range suitable for all columns and chromatographic separations. Ambient temperature +10 °C to 450 °C
- Temperature setpoint resolution: 0.1 °C
- Supports 20 oven ramps with 21 plateaus. Negative ramps are allowed.
- Maximum achievable temperature ramp rate: 250 °C/min

- Maximum run time: 999.99 minutes (16.7 hours)
- Oven cool down (22 °C ambient) 450 to 50 °C in less than 3 minutes

Electronic pneumatics control (EPC)

- Compensation for barometric pressure and ambient temperature changes is standard.
- Pressure has typical control of 0.001 psi for the range of 0 to 150 psi. Pressure setpoints may be adjusted in increments of 0.001 for the range 0.000 to 99.999 psi; 0.01 psi for the range 100.00 to 150.00 psi.
- User may select pressure units as psi, kPa, or bar.
- Pressure/flow ramps: Three maximum.
- Carrier and makeup gas settings selectable for He, H₂, N₂, and argon/methane.
- Flow or pressure setpoints for each inlet or detector parameter with both Agilent Intuvo 9000 and Agilent data system software.
- Constant flow mode is available when capillary column dimensions are loaded from the installed column(s) through the Agilent Intuvo Smart ID Key, or manually entered.
- Split/splitless and Multimode inlets have flow sensors for the control of split ratio.
- Inlet modules

Pressure sensors

Accuracy	<±2% full scale
Repeatability	<±0.05 psi
Temperature coefficient	<±0.01 psi/°C
Drift	<±0.1 psi/6 months

* Using an Agilent Intuvo 9000 with EPC (splitless), ALS, and Agilent Data System for analysis of tetradecane (2 ng to the column). Results may vary with other samples and conditions.

Flow sensors

Accuracy	<±5% depending on carrier gas
Repeatability	<±0.35% of setpoint
Temperature coefficient	<±0.20 mL/min (NTP)* per °C for He or H ₂ ; <±0.05 mL/min NTP per °C for N ₂ or Ar/CH ₄

* NTP = 25 °C and 1 atmosphere

Detector modules

Accuracy	<±3 mL/min NTP or 7% or setpoint
Repeatability	<±0.35% or setpoint

Inlets

- Maximum of one inlet installed
- EPC compensated for atmospheric pressure and temperature variation

S/SL

- Split ratios up to 12,500:1 to avoid column overload. Setting split ratios (particularly low split ratios) is limited by column parameters and control of system flows (particularly low system flows).
- Splitless mode for trace analysis. Pressure-pulsed splitless is easily accessible for best performance.
- Maximum temperature: 400 °C.
- EPC available in two pressure ranges: 0 to 100 psig (0 to 680 kPa) for best control for columns ≥0.200 mm diameter; 0 to 150 psig for columns <0.200 mm diameter.
- Gas saver mode to reduce gas consumption without compromising performance.
- Electronic septum purge flow control to eliminate ghost peaks.
- Total flow setting range:
 - 0 to 500 mL/min N₂
 - 0 to 1,250 mL/min H₂ or He
 - Turn top inlet sealing system is built in standard with each Agilent Intuvo 9000 S/SL inlet for quick, easy, injector liner changes.
 - Optional inert S/SL inlet includes chemical deactivation process for weldment and weldment insert.

Data communications

- LAN
- Two analog output channels
- (1 mV, 1 V, and 10 V output available) as standard
- Remote start/stop
- Binary-coded decimal input for a stream selection valve

Maintenance and support services

Integrated early maintenance counters allows planned maintenance and helps eliminate unnecessary downtime.

- Instrument events or shutdowns displayed on keyboard display or Data System
- Remote diagnostics
- Performance verification services
- Easy parts identification and part number finder software (standalone software, does not require Agilent CDS)

Dimensions and weight

Height	51 cm (20 in)
Width	27 cm (10.7 in)
Depth	69 cm (27.2 in)
Weight	31.8 kg (70 lbs)

Environmental conditions

- Ambient operating temperature: 15 to 35 °C
- Ambient operating humidity: 5% to 90% (noncondensing)
- Storage extremes: –40 to 70 °C
- Power requirements: Line voltage:
 - 120 VAC and 200 to 240 VAC ±10% of nominal
 - Frequency: 50/60 Hz

Safety and regulatory certification

Conforms to the following safety standards:

- Canadian Standards Association (CSA) C22.2 No. 60101-1
- Nationally Recognized Test Laboratory (NRTL): ANSI/UL61010-1
- International Electrotechnical Commission (IEC): 61010-1, 60101-2-010, 60101-2-081
- EuroNorm (EN): 61010-1

Conforms to the following regulations on Electromagnetic Compatibility (EMC) and Radio Frequency Interference (RFI):

- CISPR 11/EN 55011: Group 1 Class A
- IEC/EN 61326
- AUS/NZ CISPR11
- This ISM device complies with Canadian ICES-001. Cet appareil ISM est conforme à la norme NMB-001 du Canada.
- Designed and manufactured under a quality system registered to ISO9001, Declaration of Conformity available.

Merlin Microseal is a trademark of Merlin Instrument Company.

Agilent 5977 C MSD

Specifications

Dimensions (WxDxH) 88 cm x 56 cm x 50

GC/MSD Method Compatibility cm Yes

IDL Sensitivity (positive) Hydrolnert (hydrogen carrier gas) - 1.00 fg OFN, 1 uL injected: IDL 50 fg

IDL spec only for new GC/MS systems using H2 in split/splitless/MMI mode +Agilent checkout column +ALS

Ion Source Hydrolnert

Mass Range m/z 0.6-1091

Mode of Operation EI (standard)

QuickProbe Compatibility Yes

Scan Speed $\leq 20,000$ Da/s

Software Platform OpenLab CDS